

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b>	GENSP105
	<b>Application No.:</b>	10/726,440
	<b>Applicant</b>	Osamu Kobayashi
	<b>Filing Date</b>	December 2, 2003
	<b>Group</b>	2616
		Page 1 of 2

### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1.	6,598,161	07-22-03	Kluttz et al.			08-09-99
	2.	7,136,415	11/14/06	Yun et al.			11/12/02
	3.	7,295,578	11/13/07	Lyle et al.			09/12/01
	4.						
	5.						
	6.						

### Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	7.							
	8.							
	9.							

### Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	10.	Examination Report dated June 5, 2008 from European Patent Application No. 04252057.7
	11.	Examination Report dated June 5, 2008 from European Patent Application No. 04251581.7
	12.	Examination Report dated June 5, 2008 from European Patent Application No. 04252202.9
	13.	Office Action dated June 23, 2008 from U.S. Application No. 10/762,680
	14.	Examination Report dated June 5, 2008 from European Patent Application No. 04252056.9
	15.	Examination Report dated June 5, 2008 from European Patent Application No. 04252054.4
	16.	Examination Report dated June 5, 2008 from European Patent Application No. 04252203.7.
	17.	Chinese Office Action dated June 27, 2008 from Chinese Patent Application No. 200410038432.8
	18.	Office Action dated June 27, 2008 from U.S. Application No. 10/909,085

<b>Examiner</b>	<b>Date Considered</b>
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**Other Documents**

<b>Examiner Initial</b>	<b>No.</b>	<b>Author, Title, Place (e.g. Journal) of Publication, Date</b>
	19.	Office Action dated August 1, 2008 in U.S. Application No. 10/909,027
	20.	Chinese Office Action dated June 27, 2008 in Chinese Application No. 200410038546.2
	21.	Office Action dated June 24, 2008 from U.S. Application No. 10/726,794
	22.	Search Report dated July 21, 2008 from European Patent Application No. 08153724.3
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	24.	Kobayashi, "DisplayPort Technical Overview," <a href="http://web.archive.org/web/20060726222849/http://gnss.com/technology/DisplayPort+Technical+Overview+White+Paper.pdf">http://web.archive.org/web/20060726222849/http://gnss.com/technology/DisplayPort+Technical+Overview+White+Paper.pdf</a> , June 26, 2006.
	25.	Office Action dated July 4, 2008 from Chinese Patent Application No. 200410038545.8
	26.	Office Action dated July 2, 2008 from European Patent Application No. 04252205.2
	27.	Office Action dated May 23, 2008 from Chinese Patent Application No. 200410071498.7
	28.	Office Action dated August 8, 2008 from Chinese Patent Application No. 200410045686.2
	29.	Office Action dated August 8, 2008 from Chinese Patent Application No. 200410087460.9
	30.	VESA Display Port Standard, Version 1.1, March 19, 2007.
	31.	Office Action dated August 29, 2008 from U.S. Application No. 11/742,387
	32.	Office Action dated August 6, 2008 from U.S. Application No. 10/726,895
	33.	Chinese Office Action dated April 4, 2008 in Chinese Application No. 200410047784.X

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